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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

HIROFUMI TAKIKAWA et al.

International Appl. No.: PCT/JP2005/002479

International Appl. Date: 17 February 2005

For: POWER SUPPLY CIRCUIT FOR
PLASMA GENERATION, PLASMA
GENERATING APPARATUS,
PLASMA PROCESSING
APPARATUS AND PLASMA
PROCESSED OBJECT

Art Unit: --

Examiner: --

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that a Preliminary Amendment be entered as follows: